Search Notes

Application/Control No.	Applicant(s)/Patent under Reexamination	
09/854,463	HANNUKSELA ET AL.	
Examiner	Art Unit	
Erick Rekstad	2621	

SEARCHED					
Class	Subclass	Date	Examiner		
375	240.27 240.01 240.13 240.25		ER		
386	117		ER		
382	232		ER		
348	14.01		ER		
348	14.02		ER		
		"			

INTERFERENCE SEARCHED					
Class	Subclass	Date	Examiner		
375	240.25	5/27/2005	ER		
375	240.27	11/14/2005	ER		
	i				

SEARCH NOT (INCLUDING SEARCH)
	DATE	EXMR
IEEE: error <and> concealment <and> video</and></and>	5/27/2005	ER
IEEE, ACM Digital Library, CiteSeer, Optics Information Database search for (h.263 and supplemental enhancement)	11/14/2005	ER
keyword search	7/21/2004	ER
keyword search	5/27/2005	ER
keyword search	11/14/2005	ER
keyword search	9/1/2006	ER